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FACSIMILE COVER SHEET

TO:	Examiner Felisa C. Hiteshew U. S. Patent & Trademark Office Group Art Unit 1722		
FROM:	Damond E. Vadnais, Reg. No. 52,310		
RE:	U.S. Application No. 10/563,115 Atty. Docket No.: 03500.109446.		
FAX NO.:	(571) 273-8300		
DATE:	July 20, 2007	NO. OF PAGES:	8
		<small>(including cover page)</small>	
TIME:	1:03 P.M.	SENT BY:	LS

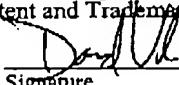
MESSAGE**Attachments:**

- 1) Amendment Transmittal
- 2) Amendment

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July 20, 2007
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JUL 20 2007

In re Application of:

Docket No. 03500.109446.

MASAKI MIZUTANI, et al.

Application No.: 10/563,115

Examiner: Felisa C. Hiteshew

371(c) Date: January 3, 2006

Group Art Unit: 1722

For: SILICON LAYER PRODUCTION METHOD
AND SOLAR CELL PRODUCTION METHOD

Date: July 20, 2007

Mail Stop Amendment
THE COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

☒ No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	* 4	MINUS	** 20	= 0	x \$25 \$50	\$0
INDEP. CLAIMS	* 2	MINUS	*** 3	= 0	x \$100 \$200	\$0
Fee for Multiple Dependent claims \$180°/\$360						\$0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$0


* If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.

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*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

- ☐ Verified Statement claiming small entity status is enclosed, if not filed previously.
- ☐ A check in the amount of \$_____ is enclosed.
- ☐ Charge \$_____ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205.
- ☐ A check in the amount of \$_____ to cover the fee for a _____ month extension is enclosed.
- ☐ A check in the amount of \$_____ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicants' undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Diamond E. Vadnais
Attorney for Applicants
Registration No.: 52,310

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Form #120

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Page 2 of 2

JUL 20 2007

03500.109446.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
MASAKI MIZUTANI, et al.) Examiner: Felisa C. Hiteshew
Application No.: 10/563,115) Group Art Unit: 1722
371(c) Date: January 3, 2006)
For: SILICON LAYER PRODUCTION)
METHOD AND SOLAR CELL)
PRODUCTION METHOD) July 20, 2007

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated June 26, 2007, please amend the
above-identified application, as follows:

Certificate of Transmision

I hereby certify that this correspondence is being facsimile
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July 20, 2007

Date

Signature

Damond E. Vadnais, Reg. No. 52,310

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